

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
)
Yamazaki et al.)
)
Serial No.:)
)
Filed: Herewith)
)
For: Semiconductor Device And Method of)
Fabricating The Same)
)
Examiner:)
)
Art Unit:)

"Express Mail" Mailing Label No.
Date of Deposit <u>321710030</u> <u>8/29/03</u>
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Signature

Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

PRELIMINARY AMENDMENT A

Prior to examination, please enter the following amendment in the above-identified application.